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CONFIRMATION NO. 3127

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|---|---|--|---------------------------------|--|---------------------------|--------------------------------|
| SERIAL NUMBER 10/596,168 | FILING or 371(c) DATE 06/02/2006 RULE | CLASS 438 | GROUP ART UNIT 2893 | ATTORNEY DOCKET NO. FIS920030346US1 | | |
| APPLICANTS Omer Dokumaci, Wappingers Falls, NY; Paul Ronsheim, Hopewell Junction, NY; ** CONTINUING DATA ***** This application is a 371 of PCT/US03/38559 12/04/2003 ** FOREIGN APPLICATIONS ***** ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/04/2008 | | | | | | |
| Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /SHWETA PRASAD Acknowledged MULCARE/ Examiner's Signature | | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY NY | SHEETS DRAWINGS 0 | TOTAL CLAIMS 20 | INDEPENDENT CLAIMS 1 |
| ADDRESS INTERNATIONAL BUSINESS MACHINES CORPORATION DEPT. 18G BLDG. 321-482 2070 ROUTE 52 HOPEWELL JUNCTION, NY 12533 UNITED STATES | | | | | | |
| TITLE Method for Forming Non-Amorphous, Ultra-Thin Semiconductor Devices Using Sacrificial Implantation Layer | | | | | | |
| FILING FEE RECEIVED 1000 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | | <input type="checkbox"/> All Fees | | |
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